

Influence of band offset and Auger recombination on the temperature sensitivity of GaInAsSb/GaSb mid-infrared lasers

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250 words

There are numerous applications for lasers in the 2-3 μm mid-infrared spectral window. Existing interband lasers suffer from increased threshold current density (J_{th}) with increasing temperature due to non-radiative processes such as Auger recombination and carrier leakage which limit their maximum operating temperature. In type-I interband devices, the band gap determines the wavelength, hence investigating the effects of band gap shift on the device properties provides a means of optimisation. In this work, temperature and hydrostatic pressure have been used independently to tune the bandgap of GaInAsSb type-I edge emitting lasers. The dependence of J_{th} , Auger current (J_{Auger}) and radiative current (J_{rad}) on the band gap of these devices is presented. Results show that by applying pressure, the T_0 of the 2.6 μm device increases from $37\pm 5\text{K}$ up to $\sim 53\pm 5\text{K}$ when operating at 2.3 μm under pressure. This value is similar to the as-grown 2.3 μm for which $T_0 = 59\pm 5\text{K}$. However, J_{th} is $\sim 25\%$ higher compared to an as-grown 2.3 μm device. This difference is due to the fact that the as-grown 2.3 μm device maintains larger band offsets than the pressure-tuned 2.3 μm device. Hence, the reduced J_{th} of the as-grown device may be associated with a lower carrier leakage current. Whilst the larger band offset helps reduce J_{th} it makes little difference to its temperature sensitivity in these type-I GaInAsSb/GaSb devices. This indicates that further optimisation of the band offset would bring little benefit in terms of T_0 and that reducing the Auger process would be of much larger benefit.

100 words

Bandgap dependent properties of type-I GaInAsSb/GaSb based lasers emitting at 2.3 μm and 2.6 μm have been investigated. The 2.6 μm device is pressure-tuned to operate at 2.3 μm with $T_0 = 53\pm 5\text{K}$ similar to the as-grown 2.3 μm device; $T_0 = 59\pm 5\text{K}$. Whilst the T_0 values are similar at 2.3 μm , the J_{th} of the pressure-tuned 2.3 μm laser is $\sim 25\%$ higher than the as-grown 2.3 μm laser due to higher carrier leakage as a result of its lower band offsets. However, as we show, T_0 is fundamentally linked to Auger recombination and for high temperature operation plays a stronger role which should be considered in the device design.